



- ☒ L5: (18636) multi-substrat
- ☒ L6: (108) multi-substrate
- ☒ L7: (96) packag\$3 and seco
- ☒ L8: (665) packag\$3 and sec
- ☒ L9: (572) 8 and (connection conductive)
- ☒ L10: (202) 9 and dielectri

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| 2 | <input type="checkbox"/> | <input type="checkbox"/> | US 6563184 B1 | 20030513 | 21 | Single crystal tunneling sensor or switch with | 257/419 | 257/254; 257/415; |
| 3 | <input type="checkbox"/> | <input type="checkbox"/> | US 6563111 B1 | 20030513 | 50 | Integrated monolithic microfabricated electrospray | 250/288 | 250/281; 250/282 |
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